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2815
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RESPONSE AFTER FINAL
EXPEDITED PROCEDURE
EXAMINING GROUP 2815

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

KIMURA

Art Unit: 2815

Application No. 09/805,102

Examiner: J. Nguyen

Filed: March 14, 2001

Attorney Dkt. No.: 107400-00026

For: SEMICONDUCTOR LASER

AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116

BOX AF
Commissioner for Patents
P.O. Box 1450
Arlington, VA 22313-1450

June 19, 2003

Sir:

In reply to the Office Action dated March 19, 2003, please amend the above-identified application as follows:

RECEIVED
JUN 23 2003
TECHNOLOGY CENTER 2800